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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
: )  
ATSUSHI KITAOKA )  
: ) Group Art Unit: 2858  
Application No.: 10/763,329 )  
: )  
Filed: January 26, 2004 )  
: )  
For: ELECTROSTATIC CAPACITANCE )  
: )  
SENSOR TYPE MEASUREMENT )  
: )  
APPARATUS ) November 5, 2004

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed below and on the enclosed Form PTO-1449. A copy of the listed document is also enclosed.

(1) JAPAN 11- 230704


This document was cited in the specification, and might be pertinent for the reasons noted therein. An English language abstract is also provided.

Inasmuch as the subject application has not yet received a first Office Action on the merits, it is believed that this Information Disclosure Statement is timely. See 37 C.F.R. § 1.97(b)(3).

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
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